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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hua Zhang et al.
Title: Fabrication of Solid-State Nanostructures
Including sub-50 nm Solid-State Nanostructures
Based on Nanolithography and Chemical
Etching
Appl. No.: 10/725,939
Filing Date: 12/03/2003
Examiner: Unassigned
Art Unit: 1762

SEQUENCE LISTING STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Per Rule 1.821(f), the applicants state that the Sequence Listing content of the paper or compact disc copy and the computer readable copy are the same, e.g., the sequence listing information recorded in computer readable form is identical to the written (on paper or compact disc) sequence listing.

Respectfully submitted,

Date

October 3, 2005

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